



503.30414V16

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): KATO, et al.

Serial No.: 09/552,572

Filed: April 19, 2000

For: VACUUM PROCESSING APPARATUS AND OPERATING
METHOD THEREFOR

Group: 2162

Examiner: S. Gravini

Allowed: February 8, 2001

Batch No.: B72

AMENDMENT UNDER 37 CFR 1.312

Assistant Commissioner for Patents

Box Issue Fee

Washington, D.C. 20231

March 26, 2001

Sir:

Subsequent to issuance of the Notice of Allowance mailed February 8, 2001, please amend the above-identified application as follows:

IN THE CLAIMS

Please amend the claims presently in the application as follows:

1. (Twice Amended) A method of transferring a substrate, using apparatus comprising:

a cassette table for mounting a cassette at a position of which an upper region of the position is open to a cassette transferring path, the cassette receiving plural substrates to be subjected to processing or plural substrates which have been subjected to processing;

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Match & Return